

PWIE, SP B.3

NCSRD activities in 2021: analysis of reference and plasma-exposed samples – plans and capabilities

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NCSR “Demokritos” (NCSRD)

Experimental capabilities for surface analysis of plasma facing materials (1)

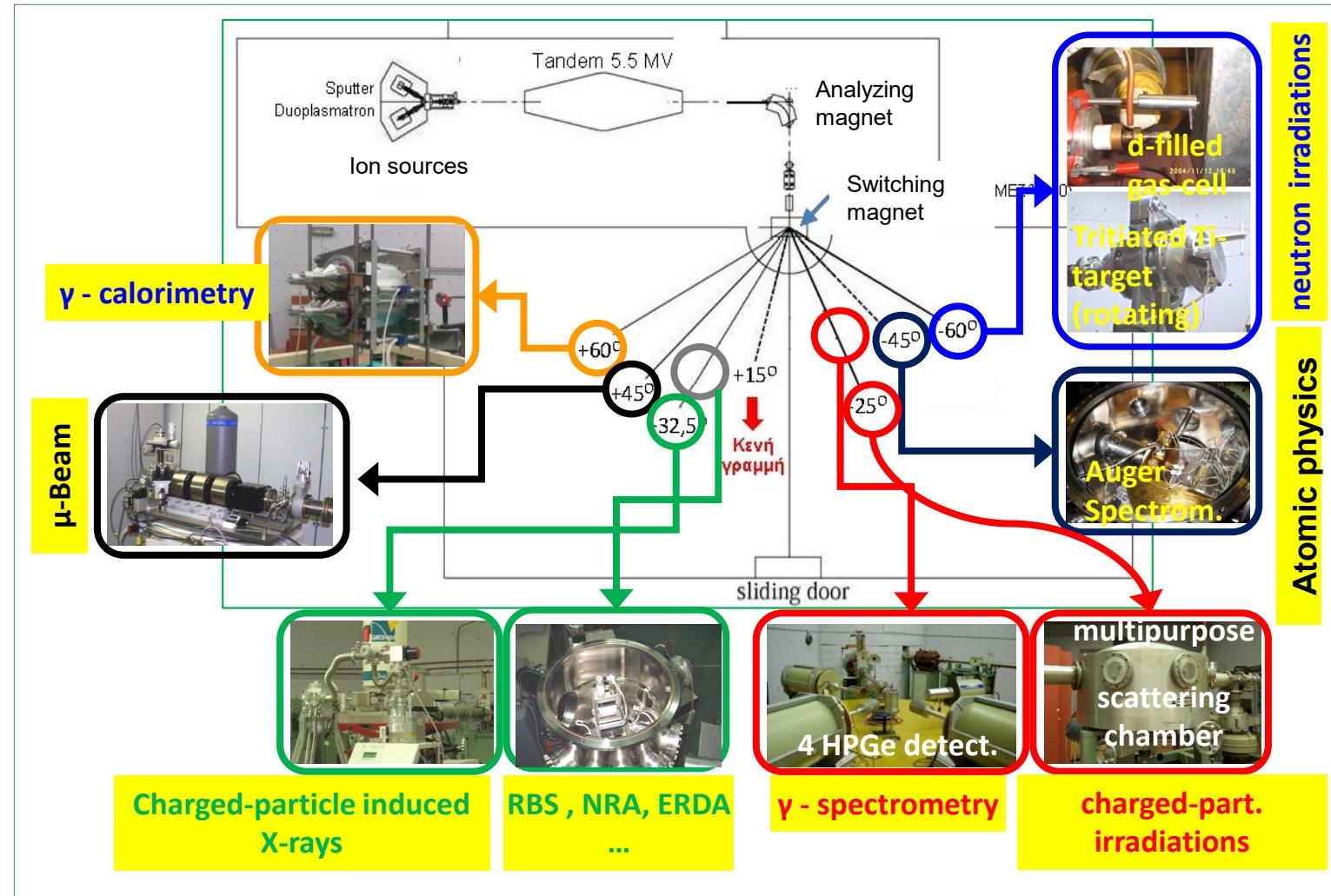


5.5 MV TANDEM Accelerator

Ion Beam Analysis

- Rutherford Backscattering Spectroscopy (RBS)
- Nuclear Reaction Analysis (NRA)
- Particle Induced X-ray/Gamma-ray Emission (PIXE/PIGE) spectroscopy
- Time-of-Flight Elastic Recoil Detection Analysis (ToF-ERDA) from early 2022
- Milli- and micro-beam

New ion sources (TORVIS & SNICS II) to be installed in early 2022 providing the ability to use ions up to Iodine



Experimental capabilities for surface analysis of plasma facing materials (2)



μ -beam Facility

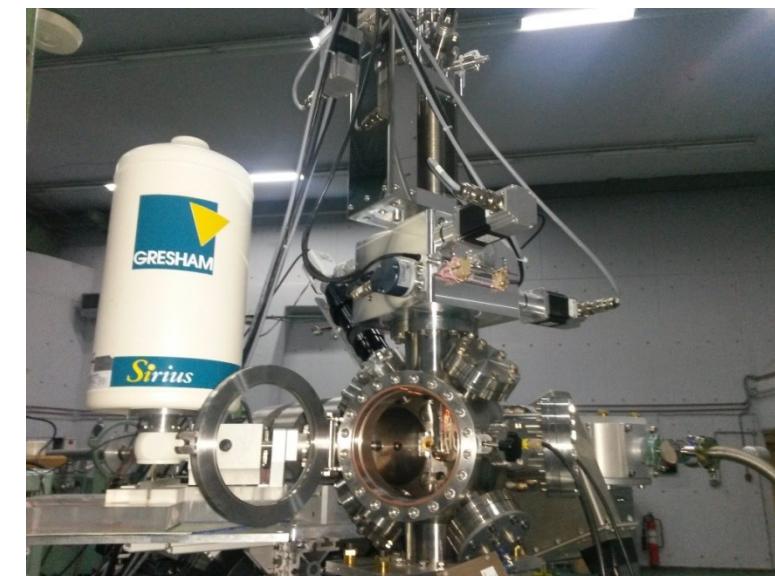
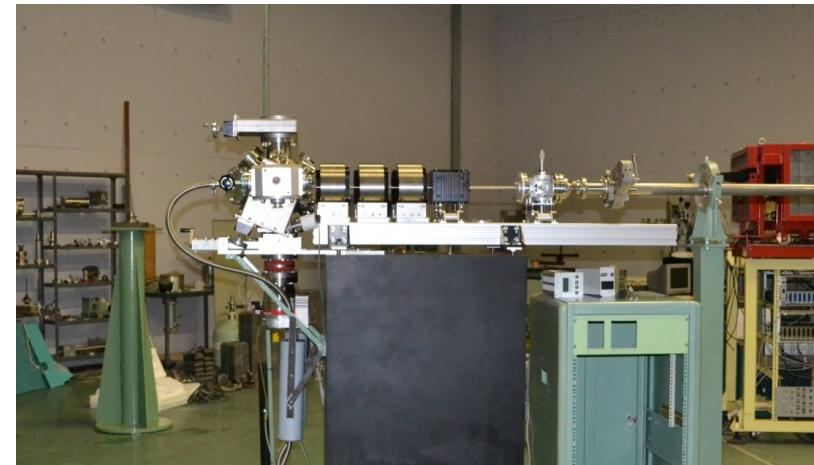
Spatial resolution 1.2 $\mu\text{m} \times 2 \mu\text{m}$

Chamber's features:

- Load – lock chamber
- 3 – axis motorized sample holder
- Rotatable target holder
- Heating / Cooling
- Long range microscope for precision
- CCD camera for sample Monitoring

Detectors:

- PIXE low energy Si(Li) detector at 45°
- PIGE HPGe detector at 45°
- STIM detector at 0°
- RBS SSB detector at 170°
- NRA SSB detector at 150°

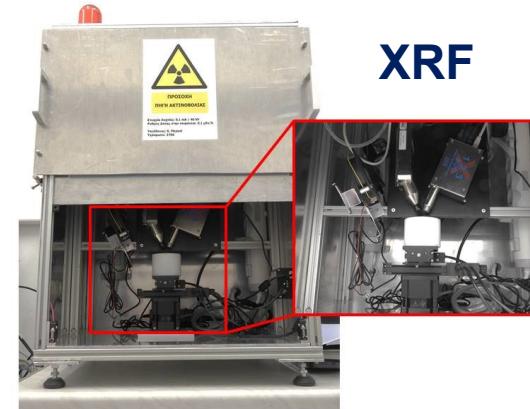


Experimental capabilities for surface analysis of plasma facing materials (3)



➤ X-ray Fluorescence Spectroscopy (XRF)

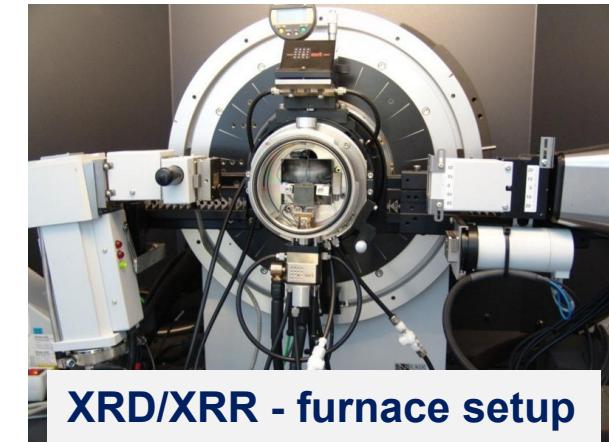
- Elemental analysis for $Z > 11$



XRF

➤ X-ray diffraction/reflectivity (XRD/XRR)

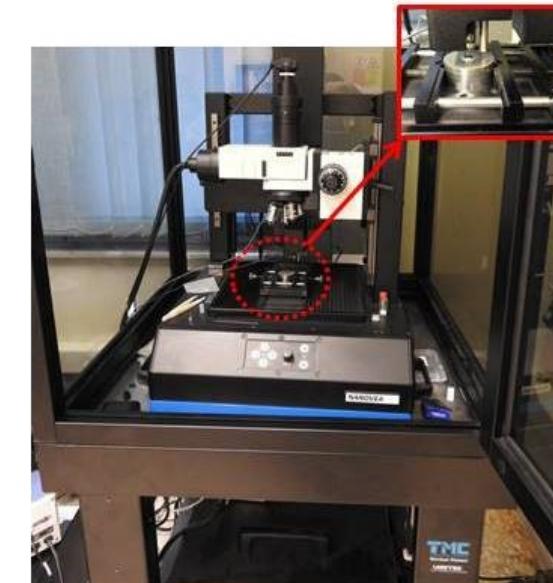
- Normal and incidence angle
- High speed linear position sensitive detector
- In-situ studies from LN₂ up to 1500 °C (XRD) or up to 800 °C (XRR)



XRD/XRR - furnace setup

➤ Scanning Electron Microscopy (SEM) with EDX spectroscopy

- <1 nm resolution 0.2-30 kV (new FEG-SEM microscope purchase under way)



➤ Transmission Electron Microscopy (TEM)

➤ Atomic Force Microscopy (AFM)

➤ X-ray Photoelectron Spectroscopy (XPS)

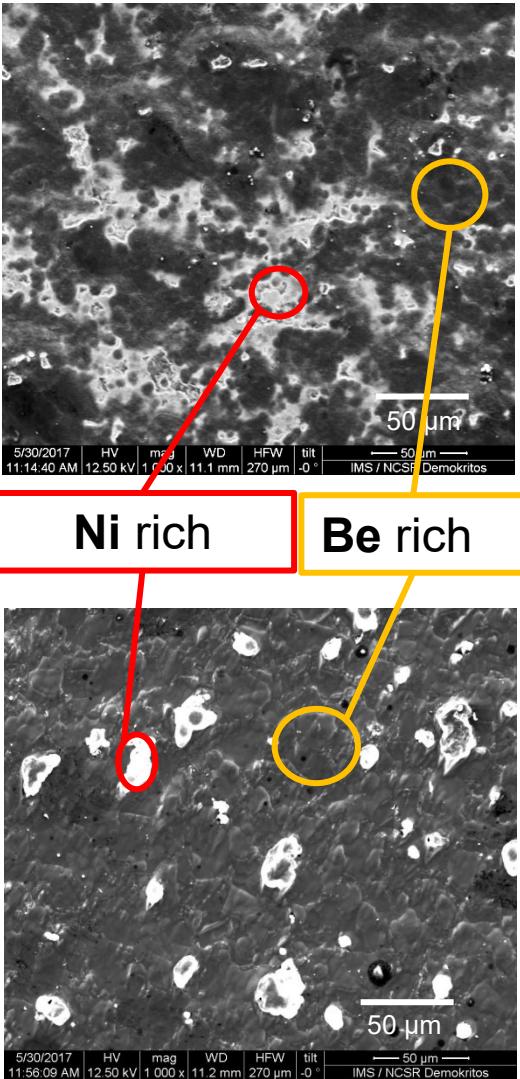
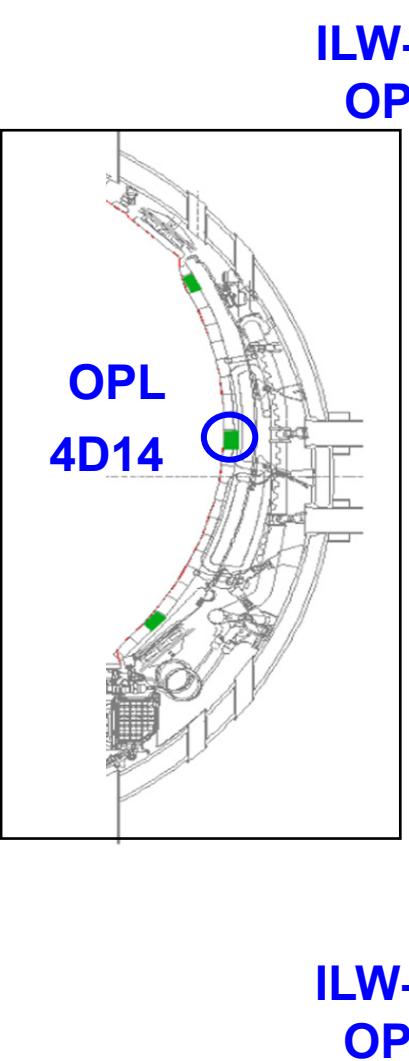
➤ Mechanical properties using depth-sensing nano- & micro-indentation

Depth Sensing Indenter

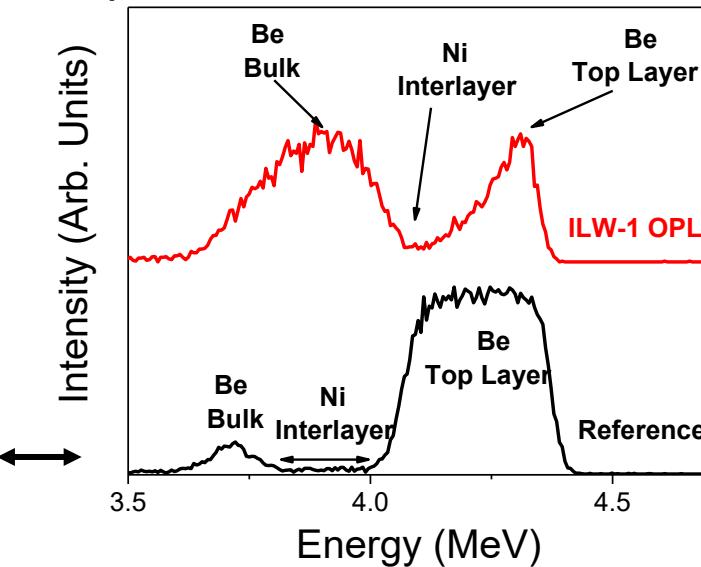
Be Tiles from JET tokamak: Erosion



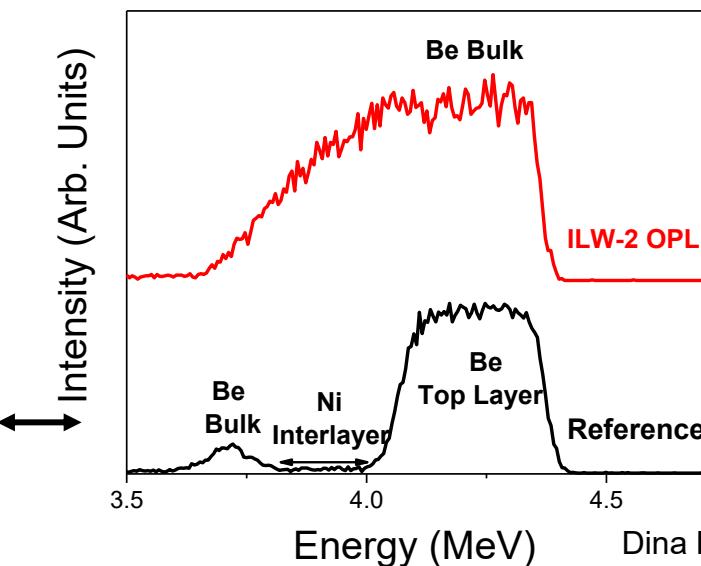
Combined NRA and SEM investigation



Comparison between ILW-1 and ILW-2



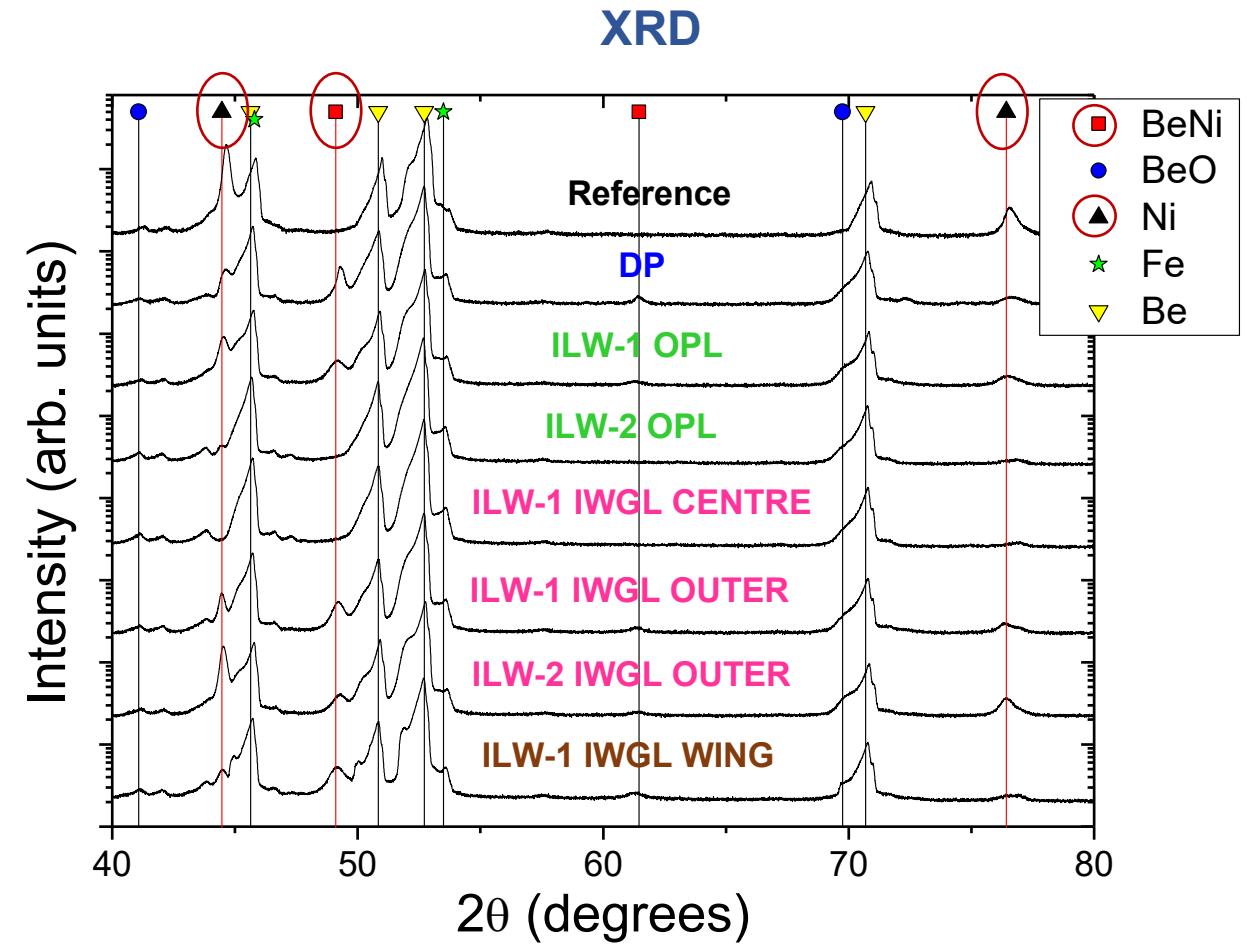
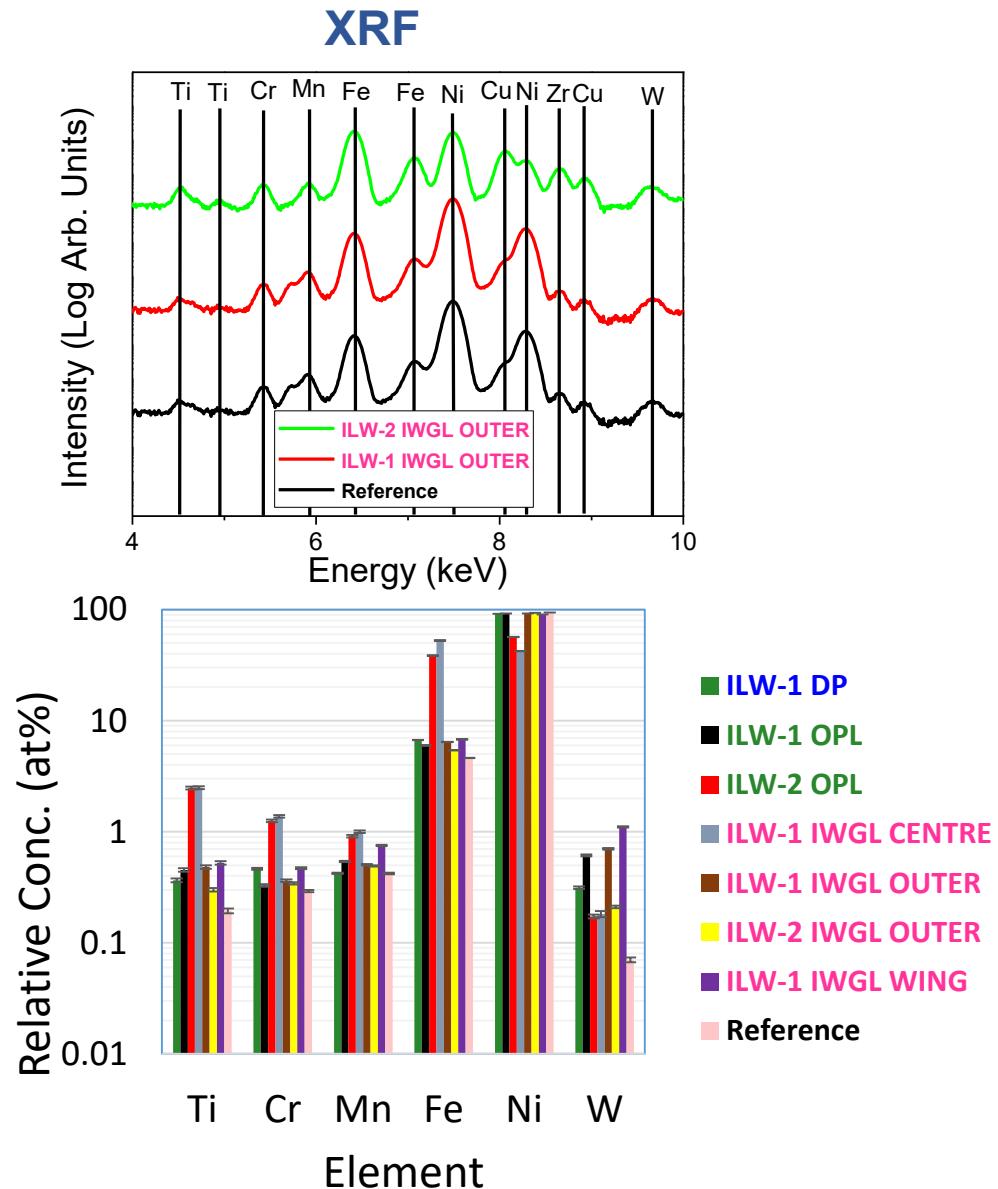
Be top layer became thinner: erosion <11 μm



Enhanced erosion (>11 μm) and deposited particles rich in Ni are observed.

Be Tiles from JET tokamak: Material deposition & compound formation

XRF & XRD investigation

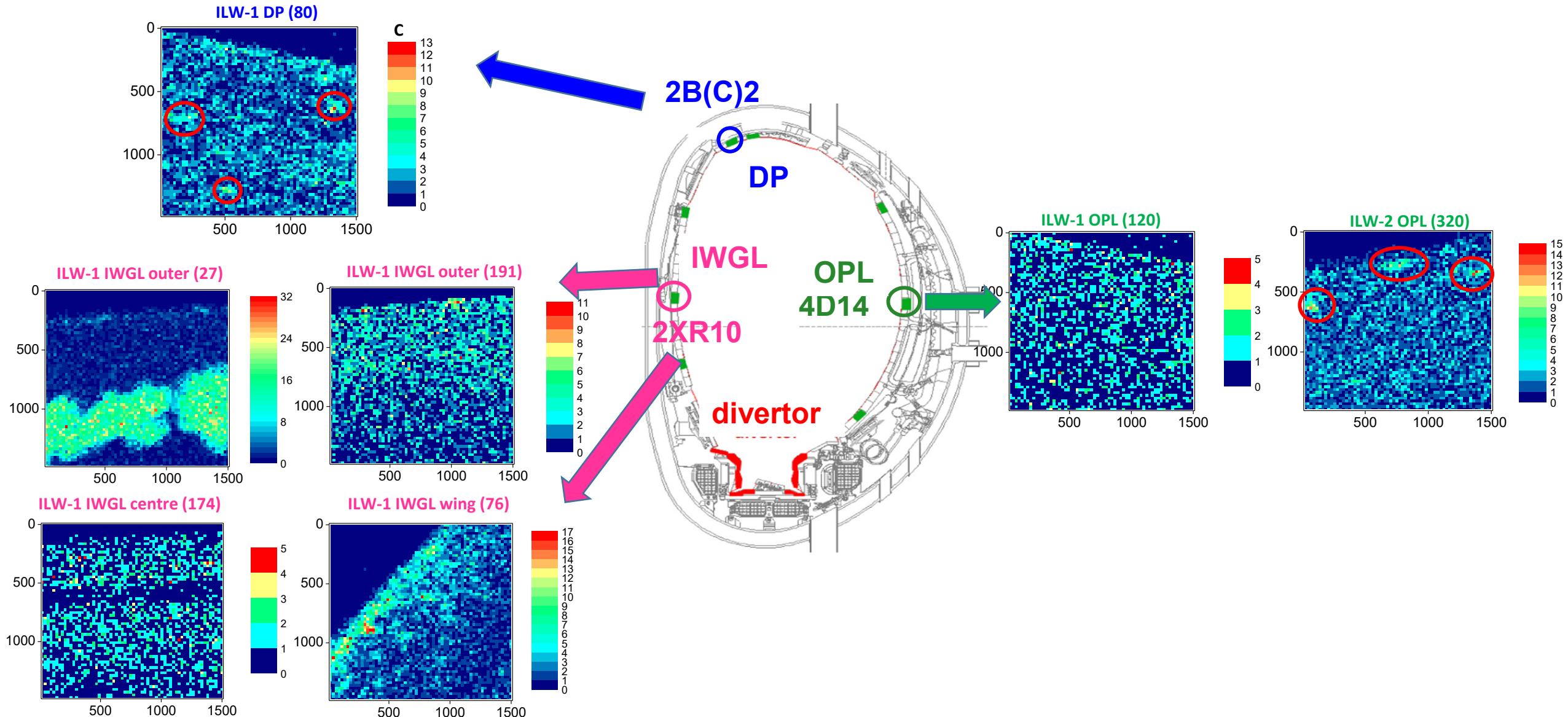


- Presence of **BeO** compound
- Formation of **BeNi** compound



Be castellated Tiles from JET tokamak

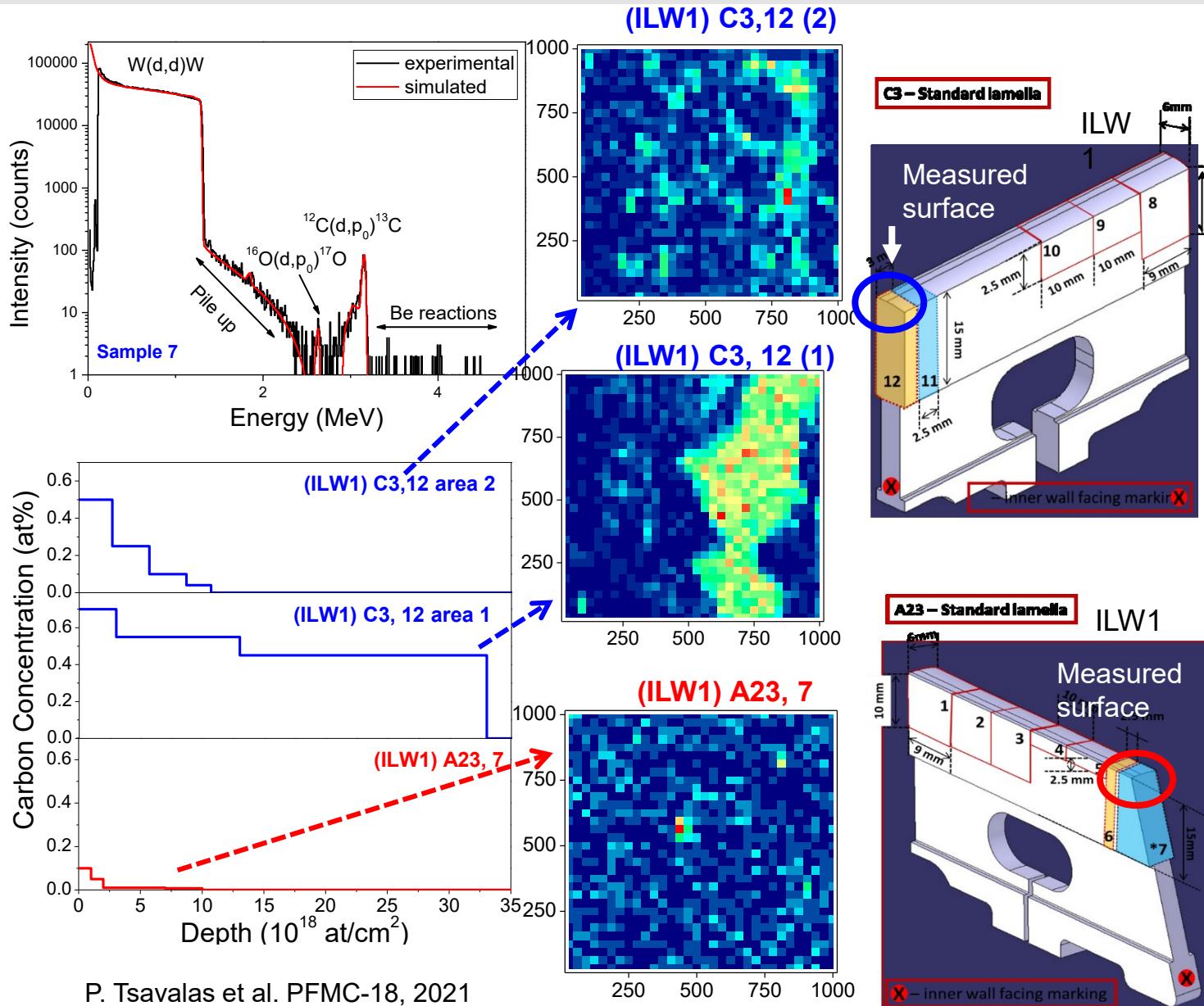
Carbon deposition on the castellated sides - μ -beam NRA using a deuterium beam





NRA results from W lamellae – use of ^2H micro-beam

Carbon deposition



Investigation of carbon deposition & carbon depth profile in W lamellae from JET tokamak

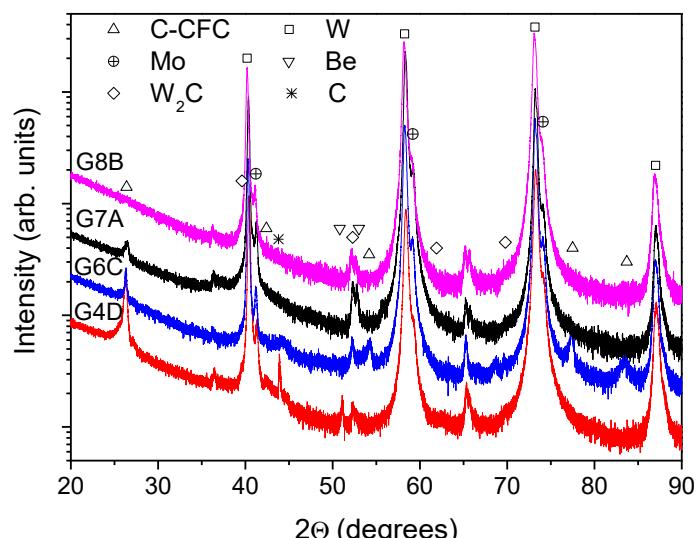
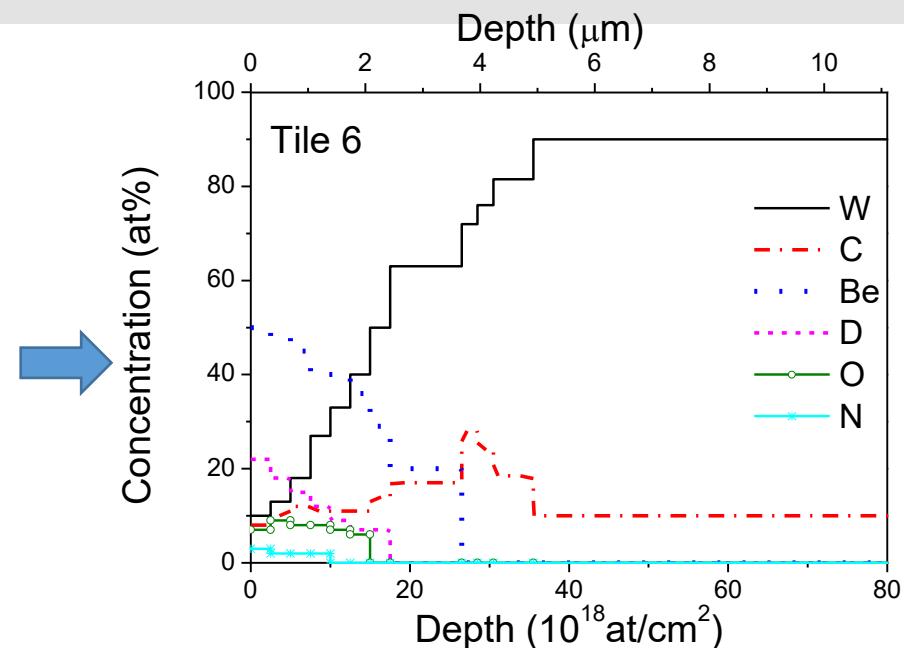
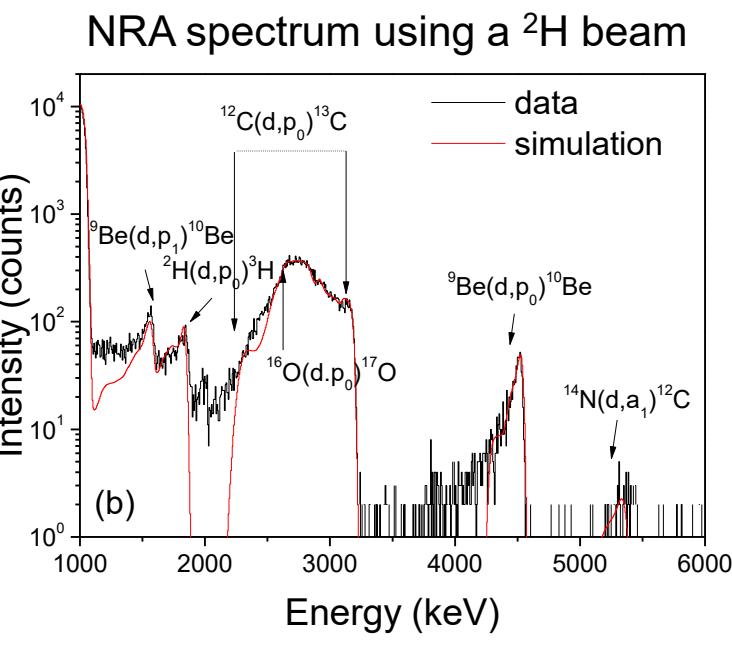
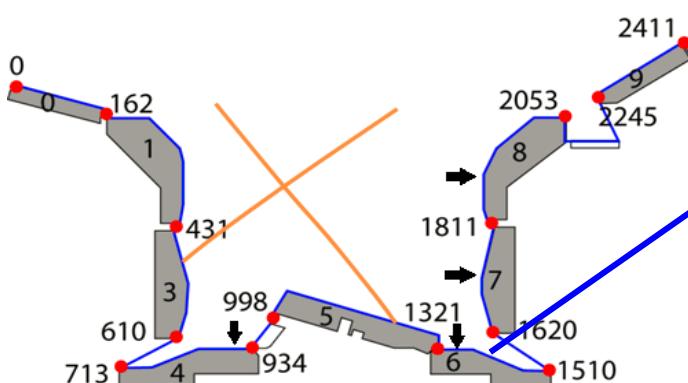
Lamella	Exp. Period	Sample	C Amount (10^{17} at/cm^2)	Deposition Thickness (10^{18} at/cm^2)
C3	ILW1	12 (2)	24.8	10.7
C3	ILW1	12 (1)	166	33
A23	ILW1	7	2.21	10

NRA and XRD results from W/CFC Tiles from the JET divertor



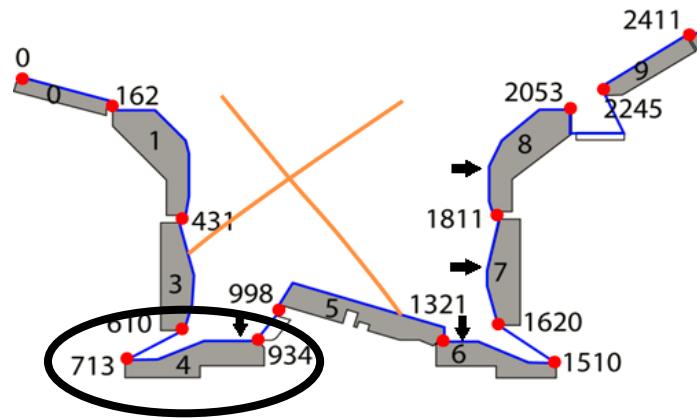
Assessment of

- Fuel retention
- Seeding species retention
- Material migration

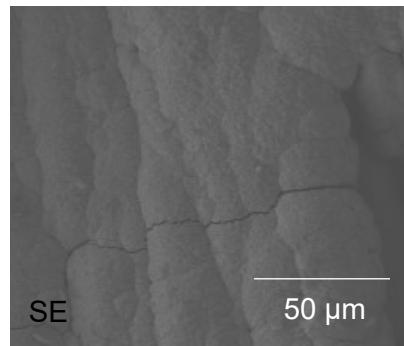


Absence of Be-W intermetallics that could affect the thermomechanical properties

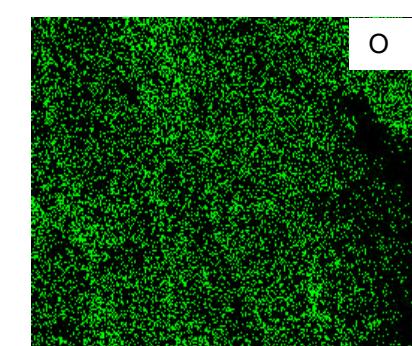
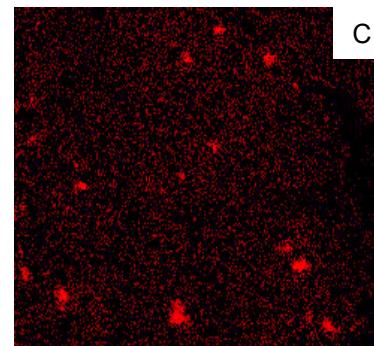
Elemental mapping from W/CFC Tiles from the JET divertor



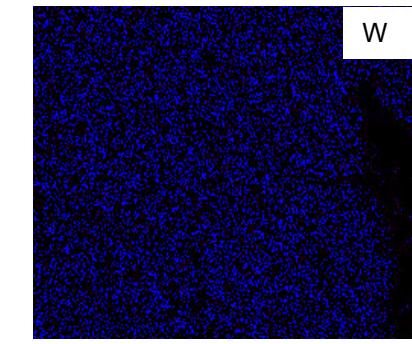
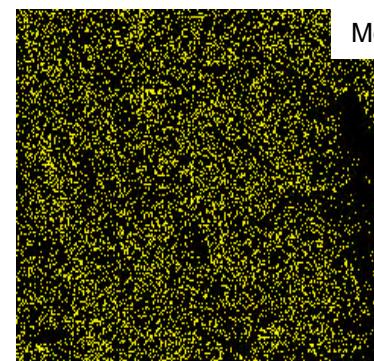
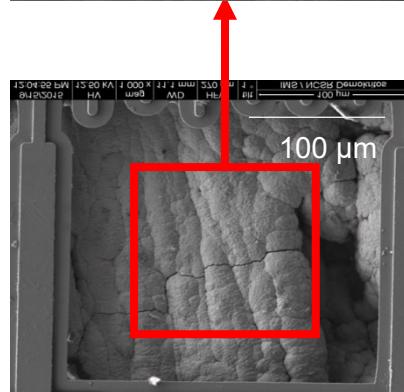
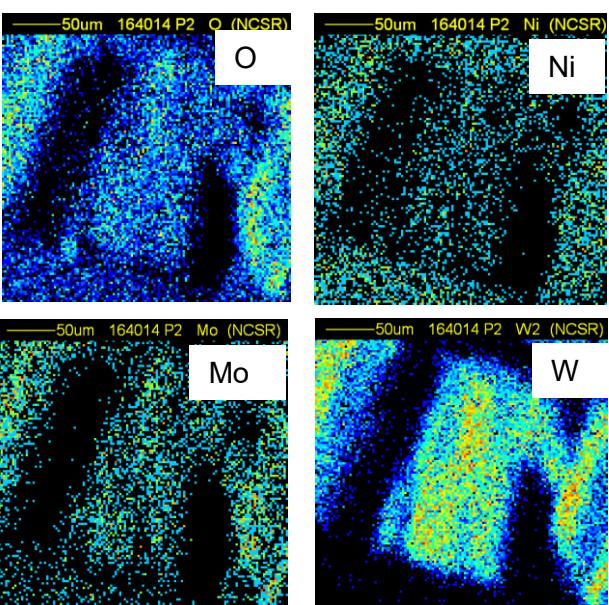
SEM Images



EDX Mapping



μ-PIXE mapping





D007

RBS, SEM, XRD and XRF characterization of selected Be reference coatings and plasma-exposed samples

Analysis of reference and plasma exposed Be or W samples from the various devices

Problems to be addressed

- Material deposition, depth profiles, compound formation
- Erosion
- Fuel retention
- Seeding species retention
- Microstructural changes
- Mechanical properties using depth-sensing indentation techniques

In-situ XRD annealing of plasma exposed samples to assess

- i) temperature effects on compound formation due to material deposition
- ii) microstructural changes.

Samples to be identified and specific problems to be defined

Suggestions for collaborations welcome (please send an email to kmergia@ipta.demokritos to discuss)